



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2851

Application No.: 09/769,832

Examiner: R. E. Fuller

Filed: January 26, 2001

Docket No.: 108455

For: PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTRIC
OPTICAL SYSTEM AND MANUFACTURING METHOD OF DEVICES

STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to a Notice of Allowance dated April 9, 2004, Applicants filed a Request for Continued Examination (RCE) and an Amendment on June 1, 2004. Applicants have not received any further communication from the Patent Office in response to the June 1 RCE and Amendment.

Applicants request the Patent Office to act on the June 1 RCE and Amendment. The Examiner is invited to contact Applicants' undersigned attorney at the telephone number listed below if there are any questions.

Respectfully submitted,

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MAC/ccs
Date: January 14, 2005
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